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# SCULLY, SCOTT, MURPHY & PRESSER



AUG 0 3 2004



XX Urg	jent	☐ For Review	☐ Please Com	ment	☐ Please Reply	☐ Please Recycle
Re:	U.S.	Cabral, Jr., et al. Patent Appln. No. Docket: YOR92003		CC:		
Phone	:			Date:	8/2/2004	
Fax:	703-	872-9306		Pages:	7 including cover	
To:		up Art Unit: 2823		From:	Leslie S. Szivos, P	h.D.

#### Dear Sir:

The following is attached hereto:

- 1. Amendment Transmittal in duplicate
- 2. Response under 37 CFR 1.111 and 1.143
- 3. Certificate of Facsimile

CONFIDENTIALITY: The documents accompanying this facsimile transmission may contain information which is either confidential or legally privileged and is intended only for the authorized use of the individual or entity named above without right or publication or republication, dissemination or disclosure except as expressly set forth or established by course of dealing. All rights are reserved. If you are not the intended recipient, you are hereby notified that any disclosure, copying, distribution or use of the contents of this facsimile is prohibited. If you received this transmission in error, please notify us immediately by telephone to arrange for return of the documents.

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		<del></del>		
CERTIFICATE OF TAPPlicant(s): Cyril Cabr	TRANSMISSION BY FAC	SIMILE (37 CFR 1.8)	VOR	Docket No. 1920030194US1 (16695)
1			1 VA	920030134U31 (10033)
Application No.	Filing Date	Examiner		Group Art Unit
10/643,534	8/19/2003	J.A. Garcia	[ ]	2823
	·	<u> </u>		
Invention: ATOMIC LA	YER DEPOSITION OF META	LLIC CONTACTS, GATES A	ND DIF	FUSION BARRIERS
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I hereby certify that this	RESPON	SE UNDER 37 CFR 1.111 AN	D 1.143	
		(Identify type of correspondence)		
is being facsimile transmi	itted to the United States Paten	t and Trademark Office (Fax.	. No. <u>703</u> -	-872-9306 )
on August 3, 2			_	
On August 3, 2	2004	•		
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			os, Ph.D.	
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, (b-b-11-2-11-12-)	MENT TRANSMIT il Cabral Jr., et al.	TAL LETTER (Larg	ge Entity)	111	cket No. 194US1 (16695)	
Application No. 10/643,534	Filing Date 8/19/2003	Examiner J.A. Garcia	Customer No 23389	. Group Art Unit 2823	Confirmation No. 4259	
Invention: ATOMIC LAYER	DEPOSITION OF ME	TALLIC CONTACTS,	GATES AND DIFF	JSION BARRIER	s	
		COMMISSIONER FOR		,		
		n the above-identified a smitted as shown below.			<u> </u>	
		CLAIMS AS AME	ENDED			
	CLAIMS REMAINING	HIGHEST#	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE	
TOTAL CLAIMS	AFTER AMENDMENT 30 -	30 =	0	x \$18.00	\$0.00	
INDEP. CLAIMS	3 -	3 =	. 0	x \$86.00	\$0.00	
	nt Claims (check if ap	olicable)			\$0.00	
Matthio Bobones		TOTAL ADDITIONAL F	FEE FOR THIS AM	ENDMENT	\$0.00	
No additional fee is required for amendment.  Please charge Deposit Account No. in the amount of  A check in the amount of to cover the filing fee is enclosed.  The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0510/IBM  Any additional filing fees required under 37 C.F.R. 1.16.  Any patent application processing fees under 37 CFR 1.17.  Dated: Angust 3, 2004						
communi	ctor is hereby authorized cation or credit any over additional filing fees of	to cover the filing ed to charge payment of rerpayment to Deposit A equired under 37 C.F.R.	fee is enclosed. If the following fees Account 50-051 In 1.16. IFR 1.17.	0/ <b>1181</b> M	nis	

CERTIFICATE OF 'Applicant(s): Cyril Cabi	YO	Docket No. R920030194US1 (16695)						
Application No. 10/643,534	Filing Date 8/19/2003	Examiner J.A. Garcia		Group Art Unit 2823				
Invention: ATOMIC LA	AYER DEPOSITION OF META	LLIC CONTACTS, GATES A	ND D	FFUSION BARRIERS				
I hereby certify that this RESPONSE UNDER 37 CFR 1.111 AND 1.143 [Identify type of correspondence]								
	is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. 703-872-9306 )  on August 3, 2004							
(Date)	·							
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No additional fee is required for amendment.  Please charge Deposit Account No. in the amount of  A check in the amount of to cover the filing fee is enclosed.  The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account 50-0510/IBM  Any additional filing fees required under 37 C.F.R. 1.16.  Any patent application processing fees under 37 CFR 1.17.							
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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Cyril Cabral Jr., et al.

Examiner: J.A. Garcia

Serial No:

10/643,534

Art Unit:

2823

Filed:

August 19, 2003

Docket: YOR920030194US1 (16695)

For: ATOMIC LAYER DEPOSITION OF

METALLIC CONTACTS, GATES AND

**DIFFUSION BARRIERS** 

Dated:

August 3, 2

Confirmation No.: 4259

Commissioner for Patents United States Patent Office Alexandria, VA 23313-1450 RECEIVED CENTRAL FAX CENTER

AUG 0 3 2004

#### **RESPONSE UNDER 37 C.F.R. §§1.111 AND 1.143**

Sir:

In response to the Office Action dated July 26, 2004, applicants provisionally elect, without traverse, the subject matter of Group I, i.e., Claims 1-22 for continued prosecution in the above-identified patent application.

## **CERTIFICATION OF FACSIMILE TRANSMISSION**

I hereby certify that this paper is being facsimile transmitted to the Patent and

Trademark Office on the date shown below.

Dated: August 3, 2004

Leslie S. Szivos, Ph.D.